

# (S53) Development of High Repetition Rate Seed Pulse at 324nm for EUV-FEL using Picosecond Thin Disk Regenerative Amplifier

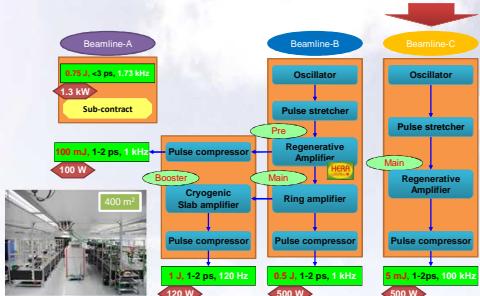


Taisuke Miura, Michal Chyla, Martin Smrž, Siva Sankar Nagisetty, Patricie Severová, Ondřej Novák, Hana Turčičová, Paweł Sikocinski, Akira Endo, and Tomáš Mocek

HilASE Centre, Institute of Physics, Czech Republic

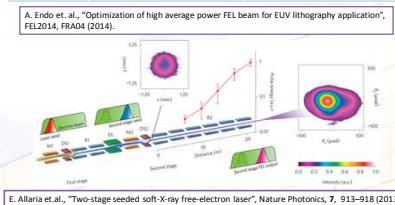
## Introduction

### Thin Disk-Based High Power Picosecond Laser Beamlines in HilASE Centre



### EUV Generation via Two-stage FEL

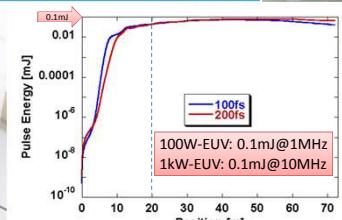
	Fermi FEL-2	EUV FEL
Seed	260 nm	324 nm
1 <sup>st</sup> FEL	32 nm	40.5 nm
2 <sup>nd</sup> FEL	10.8 nm	13.5 nm



### Scaling to Kilowatt Average Power

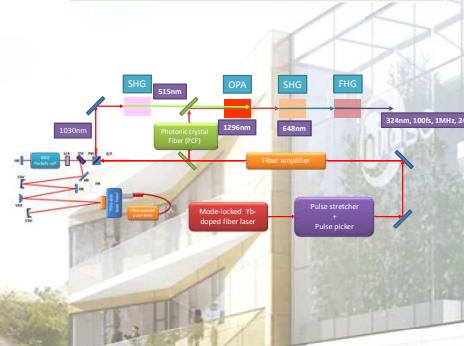
Charge	300pC	E-beam Energy	331.13MeV
Emittance	1mm•mrad	Undulator Period	9mm
Energy Spread	10 <sup>-4</sup>	K Value	1
Bunch Length	100fs/200fs	EUV Wavelength	13.5nm

#### FEL pulse energy growth along Undulator

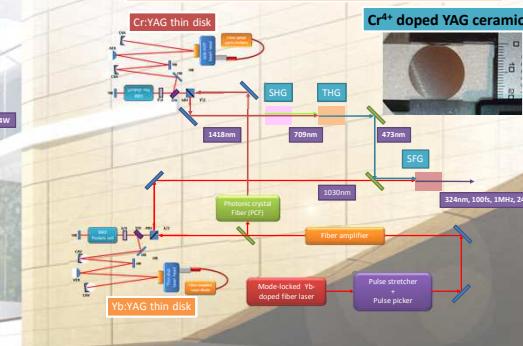


## Seed Source for EUV-FEL

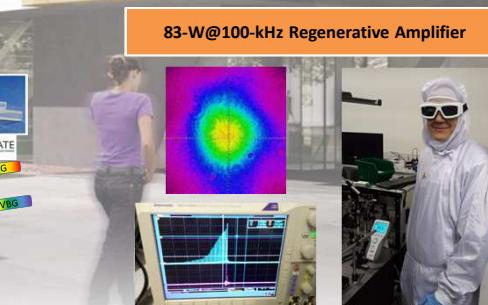
### Yb:YAG Thin Disk Based UV Seed Source using Optical Parametric Amplification



### Yb:YAG and Cr:YAG Thin Disk Based UV Seed Source for EUV-FEL

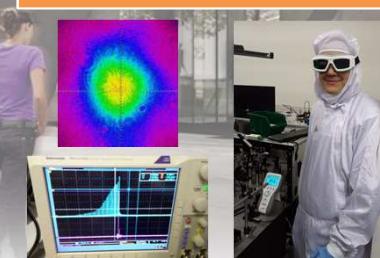


### Yb:YAG Thin Disk Based Regenerative Amplifier in Beamline C



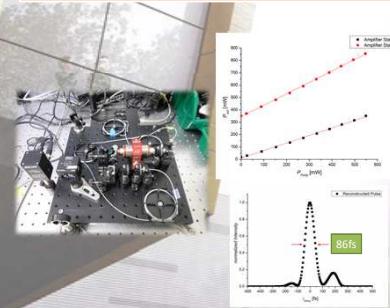
Yb:YAG thin disk soldered on CuW heatsink

### 83-W@100-kHz Regenerative Amplifier

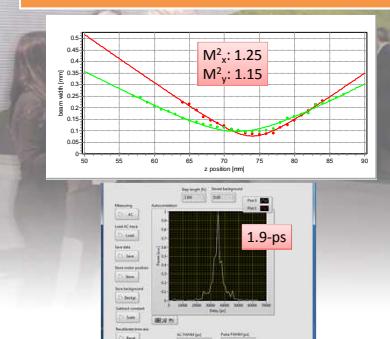


## Experimental Results

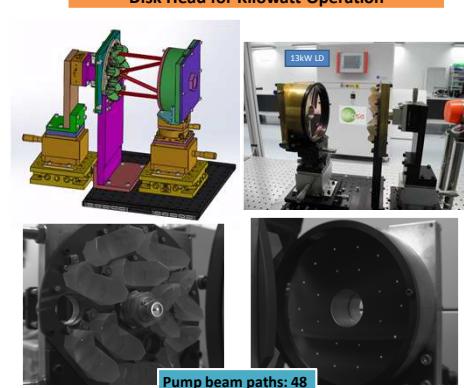
### Mode-Locked Fiber Oscillator and Fiber Amplifier



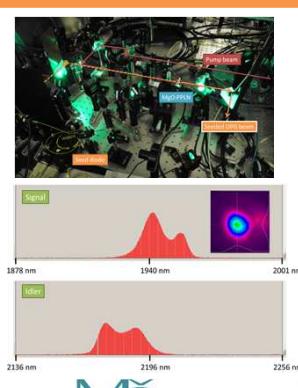
### M<sup>2</sup> and Pulse Duration Measurement



### Design and Development of Large Size Thin Disk Head for Kilowatt Operation



### Mid IR Pulse Generation



### Summary



EUROPEAN UNION  
EUROPEAN REGIONAL DEVELOPMENT FUND  
INVESTING IN YOUR FUTURE

2007-13  
OP Research and  
Development for Innovation